

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:	Group Art Unit: Unknown
Shen, et al.	Examiner: Unknown
Serial No.: 09/507,629	
Filed: 2/18/00	Docket No.: 1945.P3/USA/SILICON
For: SELF-CLEANING PROCESS FOR ETCHING SILICON CONTAINING MATERIAL	June 9, 2000
	San Francisco, California

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Attached hereto is a PTO-1449 form listing documents believed relevant to the subject application. It is respectfully requested that these documents be considered by the Examiner and an initialed copy of the form be returned to the undersigned.

Under 37 C.F.R. § 1.97(b) (3), an Information Disclosure Statement shall be considered by the Office if filed before the mailing date of the first office action.

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all documents listed herein are being deposited with the United States Postal Service as first class mail in an envelope address to: Assistant Commissioner for Patents, Washington, D.C. 20231, on June 9, 2000, by Rowena Montoya.

Therefore, it is believed that no fee is due for the filing of this Supplemental Information Disclosure Statement. However, if any fee is due, the Commissioner is hereby authorized to charge payment of any such fees to Deposit Account No. 10-0258.

Also, if any Petition is required for the filing of this Supplemental Information Disclosure Statement, such Petition is requested herein.

It should be noted that the word "prior" has been deleted from the form.

A copy of each document is enclosed.

Some of the documents may have markings thereon. No significance is meant to be attached to the markings.

With regard to any translations which may be provided herewith, the undersigned does not know how and who made the translations. Therefore, no representation is being made as to the accuracy of any translation.

These documents are not necessarily analogous.

Respectfully submitted,

JANAH & ASSOCIATES
A PROFESSIONAL CORPORATION

Date: _____

By: _____
Ashok K. Janah
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Please address all phone calls to Ashok Janah at (415)538-1555.

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Encl.